



Appln. No.: 09/783,023  
Amendment dated August 21, 2003  
Reply to Office Action of June 11, 2003

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AF 12823

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Re the Application of:

**Yoshiaki FUKUZUMI et al.**

Serial No.: 09/783,023  
Filed: February 15, 2001  
For: SEMICONDUCTOR DEVICE USING  
FUSE/ANTI-FUSE SYSTEM AND METHOD  
OF MANUFACTURING THE SAME

Atty. Docket No.: 001701:00059

Group Art Unit: 2823

Examiner: G. Fourson, III

Confirmation No.: 6061

**AMENDMENT AFTER FINAL REJECTION**

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed June 11, 2003, please amend the instant application as follows:

**Amendments to the Claims** are reflected in the Listing of Claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.